Notice of References Cited Application/Control No. 10/083,169 Applicant(s)/Patent Under Reexamination HYYPPA ET AL. Examiner Khawar Iqbal Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2003/0069792 A1	04-2003	Blumenthal, Henrik	705/16
*	В	US-2005/0026635 A2	02-2005	Michaels et al.	455/466
*	С	US-6,556,680 B1	04-2003	Leonardi, Robert	380/247
*	D	US-6,415,156 B1	07-2002	Stadelmann, Anton Niklaus	455/466
*	E	US-5,532,689 A	07-1996	Bueno, Serge	340/928
*	F	US-6,760,841 B1	07-2004	Fernandez, Alberto J.	713/172
*	G	US-2006/0039564 A1	02-2006	Rao, Bindu Rama	380/270
*	н	US-6,882,863 B2	04-2005	Hansson, Magnus	455/556.1
*	ı	US-2002/0086660 A1	07-2002	Sullivan et al.	455/406
*	J	US-6,847,816 B1	01-2005	Sarradin, Jean-Louis	455/407
*	К	US-6,853,977 B1	02-2005	Niwa, Yushi	705/21
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	α					
	R					
	S					
	Т					_

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYYY format are publication dates. Classifications may be US or foreign.